

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q93696

Masahiro FURUYA

Appln. No.: 10/574,348

Group Art Unit: 2812

Confirmation No.: 5873

Examiner: Unknown

Filed: April 3, 2006

For: METHOD FOR PRODUCING SUBSTRATE HAVING CARBON-DOPED TITANIUM
OXIDE LAYER

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

ATTN: Office of Initial Patent Examination
Filing Receipt Correction
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

We enclose a copy of the Official Filing Receipt for the above-identified application and request the following correction:

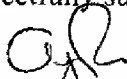
Assignment for Published Patent Application

~~CENTRAL RESEARCH INSTITUTE OF ELECTRIC POWER INDUSTRY, TOKYO,
JAPAN~~

CENTRAL RESEARCH INSTITUTE OF ELECTRIC POWER INDUSTRY

Verification for the requested correction is indicated on the Assignment document filed
April 3, 2006.

Respectfully submitted,



Abraham J. Rosner
Registration No. 33,276

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WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: February 5, 2007



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/574,348	04/03/2006	2812	1400	Q93696	7	30	2

CONFIRMATION NO. 5873

23373
 SUGHRUE MION, PLLC
 2100 PENNSYLVANIA AVENUE, N.W.
 SUITE 800
 WASHINGTON, DC 20037

FILING RECEIPT



OC00000021610627

Date Mailed: 12/15/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Masahiro Furuya, Komae-shi, JAPAN;

Assignment For Published Patent Application

[CENTRAL RESEARCH INSTITUTE OF ELECTRIC POWER INDUSTRY, Tokyo, JAPAN]

CENTRAL RESEARCH INSTITUTE OF ELECTRIC POWER INDUSTRY

Power of Attorney: The patent practitioners associated with Customer Number 23373.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/18305 12/08/2004

Foreign Applications

JAPAN 2003-411079 12/09/2003

If Required, Foreign Filing License Granted: 12/13/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/574,348**

Projected Publication Date: 03/22/2007

Non-Publication Request: No

Assignment

Whereas, I/We, Masahiro FURUYA of c/o Komae Research Laboratory, Central Research Institute of Electric Power Industry, 11-1 Iwadokita 2-chome, Komae-shi, Tokyo 201-8511 JAPAN

hereinafter called assignor(s), have invented certain improvements in

Method for Producing Substrate Having Carbon-Doped Titanium Oxide Layer
and executed an application for Letters Patent of the United States of America therefor on

February 24, 2006; and

Whereas, CENTRAL RESEARCH INSTITUTE OF ELECTRIC POWER INDUSTRY of 6-1 Otemachi 1-chome, Chiyoda-ku, Tokyo 100-8126 JAPAN

(assignee), desires to acquire the entire right, title, and interest in the application and invention, and to any United States patents to be obtained therefor;

Now therefore, for valuable consideration, receipt whereof is hereby acknowledged,

I/We, the above named assignor(s), hereby sell, assign and transfer to the above named assignee, its successors and assigns, the entire right, title and interest in the application and the invention disclosed therein for the United States of America and all countries foreign thereto, including rights of priority under the International Convention of Paris (1883) as amended, and I/we request the Director · U.S. Patent and Trademark Office to issue any Letters Patent granted upon the invention set forth in the application to the assignee, its successors and assigns; and I/we hereby agree that the assignee may apply for foreign Letters Patent on the invention and I/we will execute without further consideration all papers deemed necessary by the assignee in connection with the United States and foreign applications when called upon to do so by the assignee.

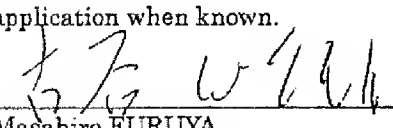
I/We hereby authorize and request our attorneys SUGHRUE MION, PLLC of 2100 Pennsylvania Avenue, NW, Washington, DC 20037-3213 to insert here in parentheses

(Application number _____ and Confirmation number _____

_____, filed _____) the filing date

and application number of said application when known.

Date: February 24, 2006



s/ Masahiro FURUYA

Date: _____

Date: _____

(Legalization not required for recording but is prima facie evidence of execution under 35 U.S.C. § 261)